



1756

Docket No.: 57454-248

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Shuji NAKAO, et al.	:	Confirmation Number: 4719
Application No.: 09/986,084	:	Group Art Unit: 1756
Filed: November 7, 2001	:	Examiner: C. Young
For: FOCUS MONITORING METHOD, FOCUS MONITORING APPARATUS, AND METHOD OF MAUFACTURING SEMICONDUCTOR DEVICE	:	

9/3/03
#6/REQ for
Recon.

REQUEST FOR RECONSIDERATION

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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GROUP 1700

Sir:

The following Remarks are submitted in response to the Office Action dated May 27, 2003.

REMARKS

At the time of the Office Action dated May 27, 2003, claims 1-9 were pending and rejected in this application.